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**FACSIMILE COVER SHEET**

To: United States Patent & Trademark Office  
Technology Center 1700, Group Art Unit 1763  
Attn: Examiner L. Alejandro

Re: Final Office Action Response

Pages including coversheet: 20

TEL No.: (703) 305-4545

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<p>CERTIFICATE OF FACSIMILE</p> <p>I hereby certify that this paper and the documents referred to as attached thereto are being transmitted by facsimile on September 4, 2003 to the United States Patent &amp; Trademark Office, Attention Luz ALEJANDRO, Technology Center 1700, Alexandria, VA 22313-1450, to facsimile number 703-872-9311.</p> <p>Signed: <i>[Signature]</i> Neely Jo Struwe</p>
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Application No.	:	09/611,037
Applicant:	:	Kuthi, et al.
Filed:	:	July 6, 2000
Title:	:	METHOD FOR IMPLEMENTING A SEMICONDUCTOR PROCESS CHAMBER ELECTRODE
TC/A.U.	:	1763
Examiner	:	Alejandro Mulero, L.
Atty. Docket No.	:	LAM1P077A
Date:	:	September 4, 2003

*Attached to this facsimile coversheet are the following documents:*

- Transmittal (1 page, in duplicate)
- Response (14 pages)
- Appendix A-Inventor Declaration (3 pages)

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## PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/611,037  
Applicant: : Kuthi, et al.  
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TC/A.U. : 1763  
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Att. Docket No. : LAMIP077A  
Date: : September 4, 2003

☐ Duplicate for  
fee processing

Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Final Office Action Response in the above-identified application.

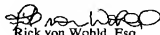
The fee has been calculated as shown below.

	Claims Remaining After <u>Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE ENTITY <u>RATE FEE</u>
TOTAL CLAIMS	<u>16</u> -	<u>20</u>	<u>0</u>	X09 = \$	OR	X18 = \$0
INDEP CLAIMS	<u>03</u> -	<u>03</u>	<u>0</u>	X40 = \$	OR	X80 = \$0
[ ] Multiple Dependent Claim Present and Fee Not Previously Paid				\$135		\$270
			TOTAL	\$		\$

☒ Applicant believes that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805

☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAMIP077A). A copy of this sheet is enclosed.

Respectfully submitted,  
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